LIGHT METALS

ALUMINUM REDUCTION TECHNOLOGY ACROSS THE DECADES: AN LMD SYMPOSIUM HONORING ALTON T. TABEREAUX, HALVOR KVANDE AND HARALD A. ØYE

An Honorary Symposium will be held for Alton Tabereaux (Reduction Cell Operation and Process Control), Halvor Kvande (Reduction Cell Technology and Developments) and Harald Øye (Fundamentals in Anode and Cathode Technology), which will be co-organized with the planned technical sessions. Manuscripts showcasing or highlighting either of the honorees are welcome.

Note regarding publication: Authors seeking an oral presentation opportunity must submit a manuscript for the proceedings or be approved for publication in a TMS journal.

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